High-Quality Zn$_{1-x}$Mg$_x$O Thin Films Deposited from a Single Molecular Source. Intimate Mixing as a Means to Improved Film Properties

Matthew R. Hill,* Jennifer J. Russell,‡ and Robert N. Lamb§

Division of Materials Science and Engineering, Commonwealth Scientific and Industrial Research Organisation, Private Bag 33, Clayton South MDC, Victoria, Australia 3169, School of Materials Science, University of New South Wales, Anzac Pde, Kensington NSW, Australia 2052, and School of Chemistry, University of Melbourne, Victoria, Australia 3101

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Zn$_{1-x}$Mg$_x$O thin films have been deposited for the first time by single-source chemical vapor deposition (SSCVD). The films were grown using novel heterobimetallic Zn/Mg carbamato cluster complexes as single-source precursors. Films were characterized with X-ray diffraction, X-ray photoelectron spectroscopy, and scanning electron microscopy, and were found to possess a single preferred crystallite orientation, high purity with consistent elemental makeup throughout the film bulk, and a dense columnar morphology. Further investigations into the films’ structures were performed using cathodoluminescence, and it was found that the incorporation of magnesium into the crystal lattice successfully quenched emissions from defect states that were otherwise observed. This provided confirmation of the first successful formation of the Zn$_{1-x}$Mg$_x$O thin film alloy through the use of SSCVD.

Introduction

Zn$_{1-x}$Mg$_x$O solid state alloy thin films have come to the fore in recent times due to the highly desirable potential of systematically engineering the bandgap, development of p–n junctions, and improving the structural properties of ZnO films through the beneficial templating effect of MgO incorporation provided to these materials. As a result of these investigations, previously unattainable applications have been realized in optoelectronic and bulk heterojunction devices. However, progress in these domains has been hampered by an inability to reliably create the Zn/Mg alloyed state through intimate mixing of zinc and magnesium residues, as most deposition techniques impose the stringent requirement for this to occur at the growth interface. The need for this additional reaction brings additional difficulty to controlling film morphology and stoichiometry. While the similarity in ionic radii between Zn$^{2+}$ (0.74Å) and Mg$^{2+}$ (0.71Å) allows for substitution of magnesium within the wurtzite ZnO lattice, we showed recently that the similar (0.71Å) allows for substitution of magnesium within the wurtzite ZnO lattice, and we showed recently that the similar (0.71Å) allows for substitution of magnesium within the wurtzite ZnO lattice, and it was found that the incorporation of magnesium into the crystal lattice successfully quenched emissions from defect states that were otherwise observed. This provided confirmation of the first successful formation of the Zn$_{1-x}$Mg$_x$O thin film alloy through the use of SSCVD.

could also be exploited to achieve similar substitution within a metal cluster complex. This involved a novel synthetic strategy, delivering Zn/Mg heterobimetallic carbamato complexes in which intimate mixing between zinc and magnesium residues had already been achieved.

Zn$_{1-x}$Mg$_x$O thin films have been generated with varying degrees of success by methods including MOCVD, PLD, and magnetron sputtering. To date, however, there have been no reports detailing the
use of single-source chemical vapor deposition (SSCVD) to prepare analogous films. SSCVD is an extremely simple technique, based on chemical precursors as opposed to deposition instruments, and in this instance could be highly advantageous in its use. In SSCVD all film constituents are supplied from the one volatile precursor molecule, which is evaporated onto a heated substrate where the desired material coalesces into a thin film. Because of the stringent criteria placed on SSCVD precursors, such precursor complexes are not commonly available, but prove to be extremely useful in the employment of an SSCVD precursor would have the added benefit of all disparate film elements being already housed within the one precursor molecule, overcoming the added complexity of forming the ZnMg1−O solid-state alloy during the deposition process, due to the heterobimetallic nature of the system.

Here, we report the first ZnMg1−O thin films deposited by SSCVD, using some novel ZnMg heterobimetallic carbamate complexes. The films are of high quality and able to be synthesized at comparatively low substrate temperatures, having been characterized by XRD, XPS depth profiling, SEM, and cathodoluminescence. Comparable films were also grown through the codeposition of previously reported separate ZnO and MgO SSCVD precursor complexes in order to quantify the effect of intimately mixed zinc and magnesium moieties on film composition, crystallinity and structure.

Experimental Section

Thin films were grown by SSCVD with precursors ZnMg8.4 (O2CNiPr2)6 (3), and ZnMg8.5O2(O2CNiPr2)12 (4) at substrate temperatures of 450, 500, 550, and 600 °C. Because all film constituents originated from within the one highly volatile molecule, no carrier or reaction gases were required. All other film growth parameters were kept constant to those used for the codeposition of 1 and 2 to allow direct comparison. Films were also co-deposited with zinc in 50–99 at % vs magnesium within the precursor mixture of ZnO(O2CNiPr2)6 (1) and Mg6(O2CNiPr2)12 (2). Against a background pressure of ~1 × 10−6 Torr, the total amount of precursor (0.50 g), the evaporation temperature (180 °C), rate of evaporation cell heating (~3 °C/min), length of deposition (2 h), and substrate temperature (550 °C) were kept constant across all depositions. XRD spectra were obtained with the use of a PW 3040/60 X’Pert Pro Diffractometer with a Cu Kα source (λ = 1.5418 Å). The step size and time per step were varied to obtain spectra of various resolutions. The height of the films within the holder was held constant by placing samples on a perspex wafer of fixed thickness, which averted potential errors of peak displacement. The films were analyzed over the full 20 range with the primary area of interest presented for clarity. XPS was performed on an ESCALAB 220i XL instrument using a monochromated Al Kα X-ray source (hv = 1486.6 eV) operated at 10 kV and 12 mA. The pressure in the measurement chamber was typically ~1 × 10−9 Torr, or 2 × 10−7 Torr during Ar⁺ etching. Samples were either screwed down, or attached by means of double sided carbon tape to aluminum holders for use in the instrument. The Ar⁺ ion gun filament was operated at ~1 μA, delivering an etching rate of approximately 1–5 Å s−1 depending on the sample composition. An electron flood gun was used in the instance of sample charging. A region of approximately 4 mm² was examined during each measurement and several regions on each sample were investigated. The step size in experiments was either 1 eV (wide scans) or 0.1 eV (high resolution region scans). The Varian “Eclipse” software V.2 was used for data processing. SEM was performed on a Hitachi 4500 scanning electron microscope. Samples were sputter coated with a thin layer of chromium in order to prevent problems with charging. Films were cleaved and mounted on the side of an aluminum sample holder using double-sided carbon tape for studies of cross-sectional film morphology. Generally, an electron accelerating voltage of 10 kV was used for imaging. Chromium coating of samples was done with a Xenosput high-resolution sputter coater. CL spectra were obtained on a Gatan

Results and Discussion

Codeposition. To investigate the requirements on potential precursors, we first deposited Zn$_x$Mg$_{1-x}$O films via the codeposition of Zn$_4$O(O$_2$CNEt$_2$)$_6$ (1)$^{51}$ and Mg$_6$(O$_2$CNEt$_2$)$_{12}$ (2).$^{49}$ These precursors have been used previously to deposit high-quality films of ZnO and MgO, respectively. Each precursor requires similar conditions to achieve a high-quality film. The ZnO precursor 1 sublimed at $\sim$180 °C, with the best-quality films being observed at substrate temperatures above 500 °C. The MgO precursor 2 sublimed at a slightly lower temperature of 175 °C, with the best films being deposited above 550 °C substrate temperature. Consequently codeposition of the two precursors from within the one evaporation cell in varying starting ratios was investigated as a possible means for the generation of Zn$_x$Mg$_{1-x}$O thin films. The deposition with varying precursor Zn:Mg ratios produced films with a range of Zn:Mg compositions. However, it was found that there was no link between the constitution of the precursor mix and the thin films obtained.

The makeup of the films was seen to change throughout the bulk, as evidenced by the XPS depth profiling in Figure 1. This typical spectrum revealed that the Zn:Mg film composition varied significantly throughout the bulk. The amount of magnesium present in the thin film samples increased as the etching proceeded further into the bulk, reaching a maximum at the substrate. This was attributed to the magnesium precursor 2 subliming at a lower temperature than the zinc complex 1, resulting in a film in which the magnesium content diminished as its relative precursor flux diminished throughout the deposition.

Cathodoluminescence spectra were taken of the codeposited films and were corrected for instrumental response to determine if any blueshift of the bandgap of the films was achieved, an indication of whether an alloyed state had been formed. Once again, the results showed some variations, but could not be correlated to the elemental composition of the film. Some representative spectra are highlighted below in Figure 2. A small peak was seen at $\sim$3.4 eV, corresponding to the band edge emission of ZnO. Much stronger, broader peaks were observed in the range 2–3 eV, and were assigned as being due to defect emissions. The blueshift is very small (if any) and does not correlate to the significant magnesium levels. The effect is more likely due to some morphological aspects of the films. This indicates that the film is MgO + ZnO as opposed to Zn$_x$Mg$_{1-x}$O. Moreover the defect emission peak (2–3 eV) is in all cases substantially larger than the band edge emission, indicative of undesirable structural defects.

SEM revealed further problems with the codeposition technique. In all cases, the amount of precursor material sublimed and the deposition time were kept constant at 0.50 g and two hours respectively. However, film thicknesses observed were exceptionally varied, ranging between 200 nm and 6 µm. The films all showed a dense structure with poorly defined columns. The images shown in Figure 3 highlight the different film thicknesses that were obtained under otherwise identical film growth conditions. The films in these images are $\sim$1 and 3 µm thick, respectively. The variation in film thickness is another example of the inherent unreliability of codeposition, where the rate at which the film grows is likely to be influenced by the initial nucleation at the interface, and the suitability of this phase as a template for coalescing precursor vapors that follow, i.e., whether enough ZnO crystallites form at the interface for the following ZnO precursor vapors to have a favorable template for film growth.

The codeposition of the magnesium diethylcarbamato hexamer 2 and the zinc diethylcarbamato tetramer 1 to produce Zn$_x$Mg$_{1-x}$O thin films proved to be problematic. XPS revealed that consistent Zn:Mg ratios could not be achieved in the bulk unless an excess of magnesium was present, which resulted in an undesirable crystal phase being formed (XRD). Cathodoluminescence did not show a blueshift of the bandgap commensurate with the levels of magnesium in the film. SEM highlighted further degrees of unreliability in the technique, with films of wildly differing thicknesses being derived from otherwise identical growth conditions. The results indicate that codeposited thin films were mixtures of ZnO and MgO (amorphous and crystalline phases) as opposed to Zn$_x$Mg$_{1-x}$O. Clearly, the mixing of the two metals by this approach lacked the required intimacy for the alloyed phase to form.

Heterobimetallic Precursors. Thin films were deposited using the heterobimetallic precursor complexes Zn$_3$Mg$_{1-x}$O(O$_2$CNPF$_3$)$_6$ (3) and Zn$_{7.3}$Mg$_{6.2}$O(O$_2$CNPF$_3$)$_{12}$ (4), the syntheses of which having been described elsewhere.$^{39}$ The
degree of intimate mixing between zinc and magnesium in these molecules was greatly enhanced, increasing the likelihood that a thin film alloy could be deposited. XPS depth profiling was crucial for determining whether the mixed metal precursors 3 and 4 improved the consistency of elemental makeup throughout the films when compared to...

Figure 3. Typical SEM images showing the large variance in film thickness for codeposited films.

Figure 4. XPS depth profiling of films grown with low Mg content complex 3 at 450–600 °C.

Figure 5. XPS depth profiling of films grown with high Mg content 4 at 450–600 °C.
the codeposited samples described above. In general, films deposited with these heterobimetallic precursors displayed greatly enhanced consistency in their makeup throughout the film bulk, although in some cases the levels of magnesium incorporation were quite low.

Apart from the initial carbon rich surface layers, elemental compositions were otherwise constant throughout the bulk of the films. The deposition temperature has little effect on elemental composition, with the exception of films deposited at 600 °C. In this case the levels of carbon (ca. 30%) and magnesium (ca. 8%) were substantially elevated, repeatable over several depositions. It is likely that the high substrate temperature caused the precursor to break down too quickly for the carbonaceous ligands to escape from the coalescing material, resulting in an undesirable high carbon content film.

The primary difference in films grown with the higher magnesium content precursor 4 is a corresponding increase in the magnesium doping levels. Once again, the improved consistency of elemental makeup throughout the bulk, and the unusual constitution of films grown at 600 °C were evident. The zinc:magnesium ratios correlated well to those found in the structure refinement for 4.39

X-Ray diffraction patterns for films deposited with 3 and 4 are shown in Figures 6 and 7. With the exception of films deposited at 600 °C (see XPS results) all films displayed a crystalline wurtzite \( \text{Zn}_x\text{Mg}_{1-x}\text{O} \) structure with preferred c-axis out-of-plane orientation. Even though Mg contents above 2 at % are not considered thermodynamically stable, no phase separation into ZnO and MgO components was witnessed. In part, this was because of the preorganization metals in the precursor and the low growth temperatures it made possible. The peaks were sharper and better defined for films derived from the low magnesium content derivative 3. This is due to the comparatively higher level of magnesium doping in films of 4, which introduce an amount of strain in the \( \text{Zn}_x\text{Mg}_{1-x}\text{O} \) crystal, thus reducing its average crystallite size. Notably, the spectra indicate the successful formation of a single preferred out of plane crystallite orientation.

SEM revealed that films deposited with this technique had much more uniform thicknesses than those codeposited from separate sources 1 and 2. The cross-sectional morphology of the films was similar to that generally witnessed in films deposited by SSCVD, as shown in

Figure 6. XRD patterns of films grown with the low-Mg-doped precursor 3.

Figure 7. XRD patterns of films grown with the high-Mg-content precursor 4.

Figure 8. The films were columnar in nature, with the columns becoming more defined as the growth temperature was increased. The columns are packed closely together within the film, but as shown in Figure 9, spaces between the columns are clearly evident from a top view. This serves to underline that films produced by SSCVD are generally low-density materials.

As shown in Figure 10, cathodoluminescence spectra were taken on films derived from 3 and 4. In comparison to the results obtained from films codeposited from 1 and 2 (Figure 2), the most notable variation with these spectra was the suppression of defect states (2–3 eV). In the spectra of codeposited films, the defect states delivered an emission of greater intensity than the primary band edge (3.4 eV), whereas in the instance of films deposited from the novel precursors 3 and 4, the defect emission peak was either eliminated or greatly reduced, while the band edge emission was found to be much stronger. This phenomenon has been observed previously by Zhang and co-workers12 who proposed that the presence of magnesium improved the structural order of the polycrystalline thin film, increasing its excitonic nature. Consequently the defect emissions were greatly suppressed in comparison to the main band edge. This suppression of defect states compared to reference films is solid evidence of the successful formation of the mixed metal alloyed state. In addition, the improvement in structural order as shown in Figure 10 is much more significant in films of 3 relative to those derived from the higher magnesium content 4 (in agreement with XRD results). This is likely to be due to the different structural chemistry of the two precursor materials39 and the subtle variations in the interfacial chemistry that this brings. There was possibly a small blueshift for the magnesium substituted films, although at the substitution levels reported here large shifts would not be expected. Overall the CL data for films derived from mixed metal intermediates 3 and 4 was very promising. It confirmed the successful formation of the \( \text{Zn}_x\text{Mg}_{1-x}\text{O} \) alloy and demonstrated structural improvement due to magnesium incorporation.
Summary and Conclusions

Codeposition of separate ZnO and MgO SSCVD precur-
sors $\text{Zn}_4\text{O(O}_2\text{CNEt}_2)_6$ (1) and $\text{Mg}_6(\text{O}_2\text{CNEt}_2)_{12}$ (2) was
investigated as a means to the SSCVD of $\text{Zn}_{x}\text{Mg}_{1-x}\text{O}$. Characterization of these films indicated that they were
a mixture of amorphous and crystalline MgO and ZnO, as
opposed to the $\text{Zn}_{x}\text{Mg}_{1-x}\text{O}$ alloy. This phase separation was
attributed to a lack of intimate mixing between zinc and
magnesium moieties prior to reaching the growth interface.
Investigation of the light emission properties of these films
revealed the presence of a large number of defect states, a
phenomenon commonly observed in SSCVD films. On the
other hand, in a highly significant result, $\text{Zn}_{x}\text{Mg}_{1-x}\text{O}$ alloys
were derived from depositions using the heterobimetallic
derivatives $\text{Zn}_x\text{Mg}_{4-x}\text{O(O}_2\text{CNiPr}_2)_6$ (3) and $\text{Zn}_{7.38}\text{Mg}_{0.62}\text{O}_2$-
$(\text{O}_2\text{CNiPr}_2)_{12}$ (4). In these complexes, the two metal atoms
were intimately mixed by being housed within the one
precursor molecule, and could be used to deposit the desired
$\text{Zn}_x\text{Mg}_{1-x}\text{O}$ alloy for the first time with SSCVD by achieving
heterobimetallic preorganization prior to film deposition.
Characterization of these films revealed a single preferred
crystalline orientation, attainable at comparatively low
substrate temperatures. The degree of strain and change in
crystallite size was evident from a broadening of XRD peaks
correlating to increased magnesium substitution. The el-
mental makeup of the films was found to be relatively free
of contamination, and far more stable throughout the bulk
of the film in comparison to codeposited analogues. In stark

Figure 8. Typical SEM images of film cross-sections grown at 450 °C (left) and 550 °C (right).

Figure 9. Top views of films by SEM.

Figure 10. Cathodoluminescence spectra of films from mixed-metal precursors.
contrast to codeposited materials, cathodoluminescence spectra of these films showed that the presence of magnesium within the crystal lattice quenched defect emission peaks and enhanced the main band edge emission, a phenomenon commonly associated with the successful formation of the Zn$_x$Mg$_{1-x}$O alloy. Moreover some blueshifting was witnessed. The heterobimetallic carbamato complexes 3 and 4 have been demonstrated to be excellent precursors in the first reported SSCVD of Zn$_x$Mg$_{1-x}$O thin film alloys, yielding films of high quality. The unlocking of SSCVD as a means to the generation of Zn$_x$Mg$_{1-x}$O thin films represents an important expansion in the fields of application for an important emerging thin film material.

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